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Form PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Atty Docket No. HARAP0166US	Express Mail No. EV710253666US
	Applicant: Morito AKIYAMA, et al.	
	Filing Date November 11, 2005	Group Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date MM/YYYY	Name	Class	Sub-class	Filing Date if Appropriate

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date MM/YYYY	Country	Class	Sub-class	Translation	
						Yes	No
/DR/	2004-200843	07/2004	JP			Abstract	

OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
/DR/	International Search Report for corresponding PCT/JP2004/006553, mailed, August 24, 2004.
↓	Morito Akiyama et al.; "Statistical approach for optimizing sputtering conditions of highly oriented aluminum nitride thin films", Thin Solid Films, 1998, Vol. 315, p. 62-65.
↓	Morito Akiyama et al.; "Influence of sputtering target material on crystallinity and orientation of AlN thin films", Journal of the Ceramic Society of Japan, 2002, Vol. 110, p. 115-117.
↓	Mikito Kamijo et al.; "Study of deposition of colored films by sputtering method", No. 14, 2000, p. 31-35.
↓	Yoshihito Maeda et al.; "Direct overwriting in InSbTe phase-change optical disk and the mechanism"; 1988, Vol. 88, No. 388, p. 47-52.
↓	Toshihiro Kamohara, et al.; "Improvement on crystal orientation of AlN thin films by AlN Nanointerlayers", March 28, 2004, No. 1, p. 402, 30p-YN-3.
/DR/	Morito Akiyama et al.; "Improvement on orientation of AlN thin films by Laminated Electrodes", March 27, 2003, No. 2, p. 691, 30a-S-3.

EXAMINER /Derek Rosenau/	DATE CONSIDERED 10/07/2008
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

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